

<b>Notice of References Cited</b>	Application/Control No. 09/980,754	Applicant(s)/Patent Under Reexamination LERCH ET AL.	
	Examiner Julio J. Maldonado	Art Unit 2823	Page 1 of 1

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**NON-PATENT DOCUMENTS**

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	U	Wolf, Stanley and Tauber, Richard N.; Silicon Processing for the VLSI Era Vol I: Process Technology; 1986, Lattice Press, pgs 192-194
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.